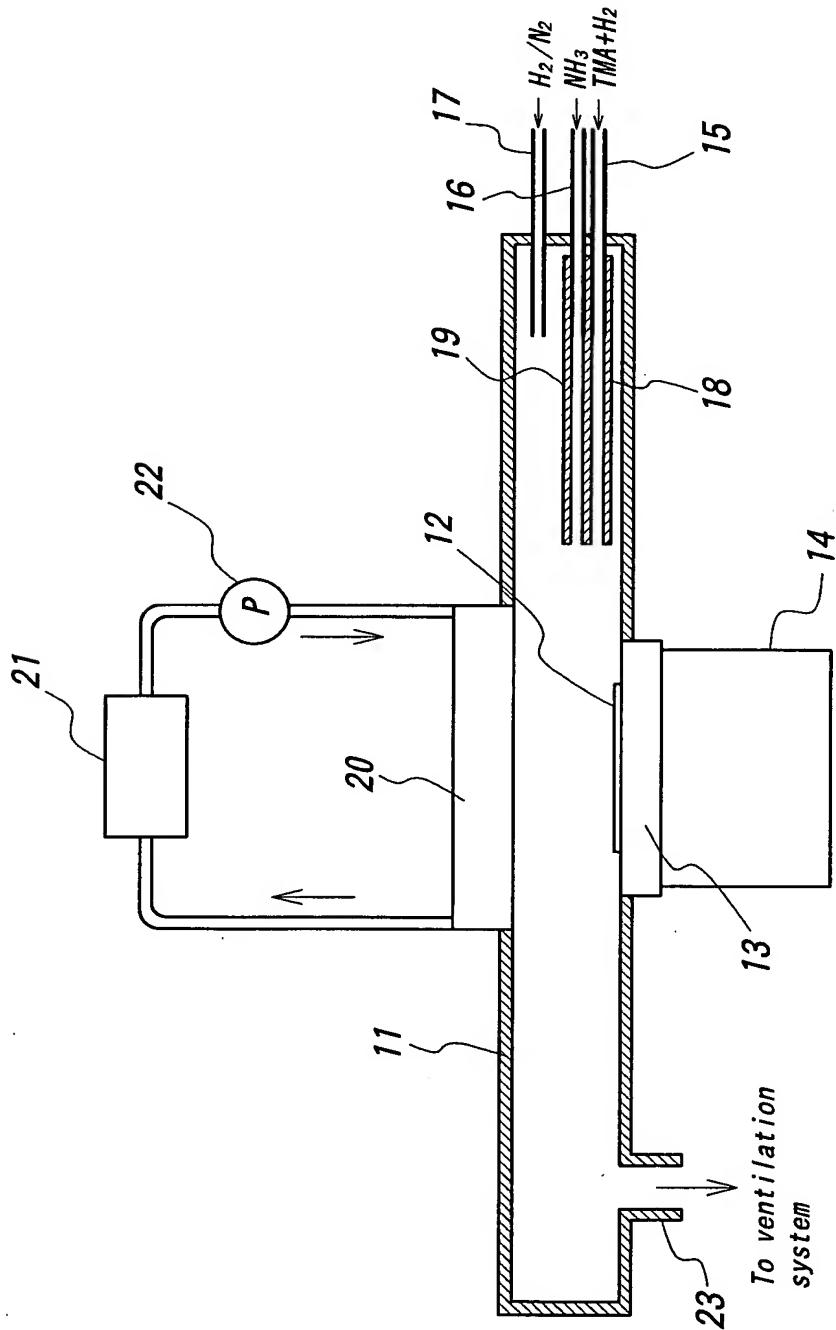


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FIG. 1



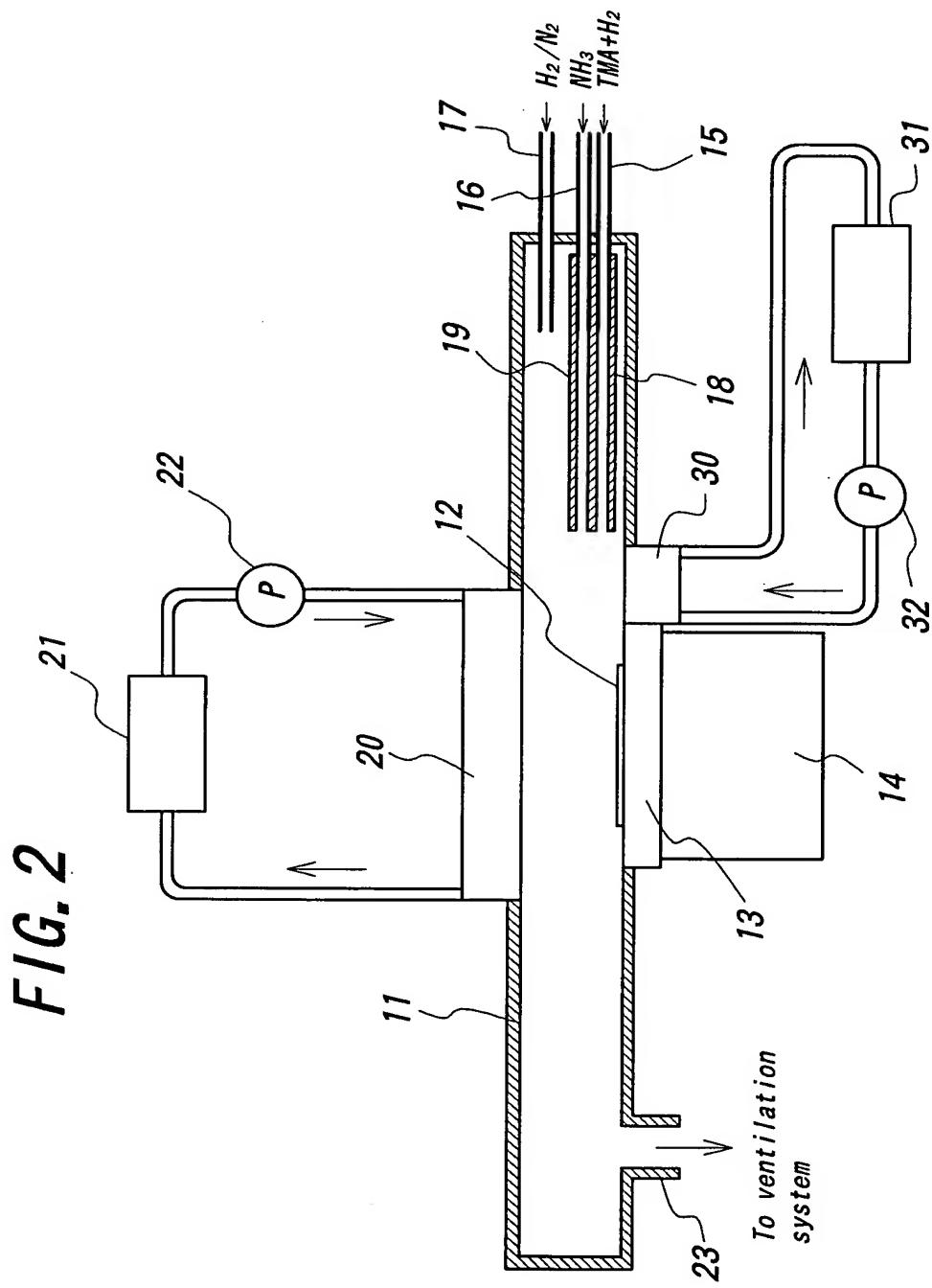
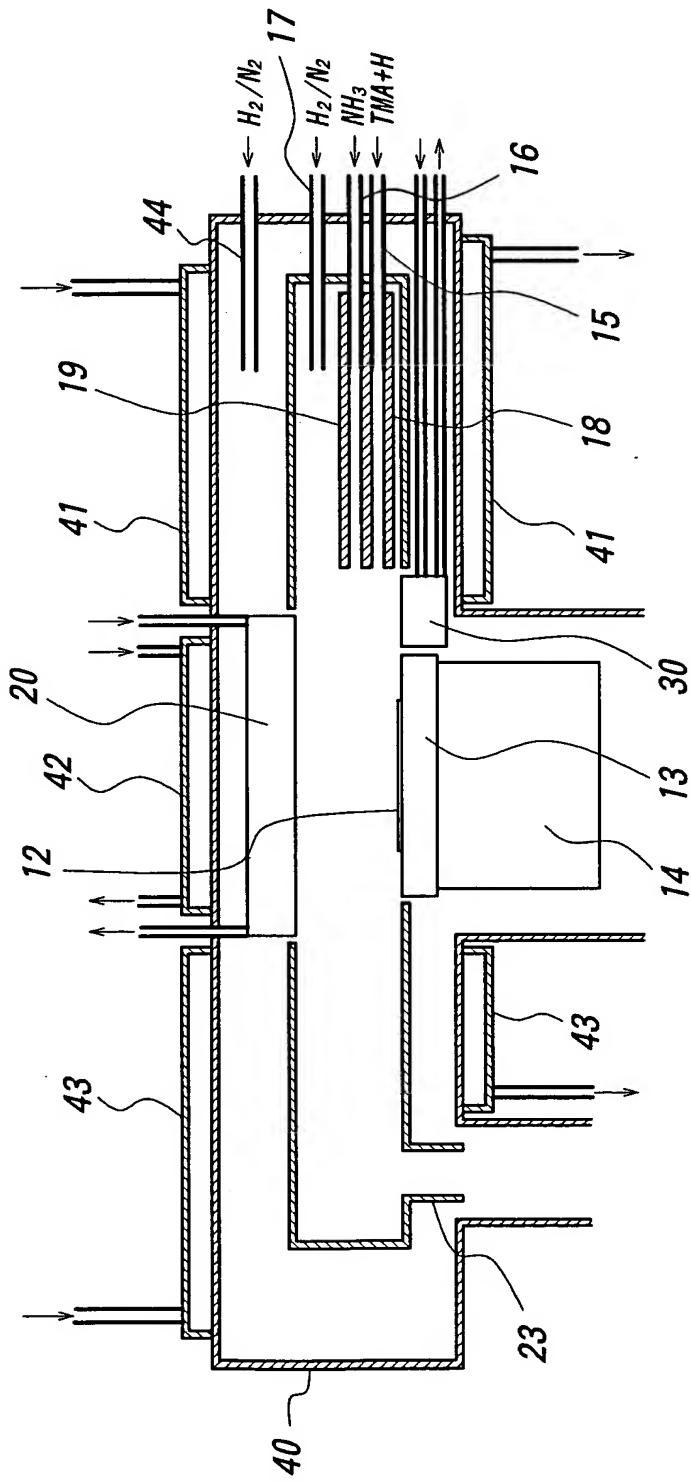


FIG. 3



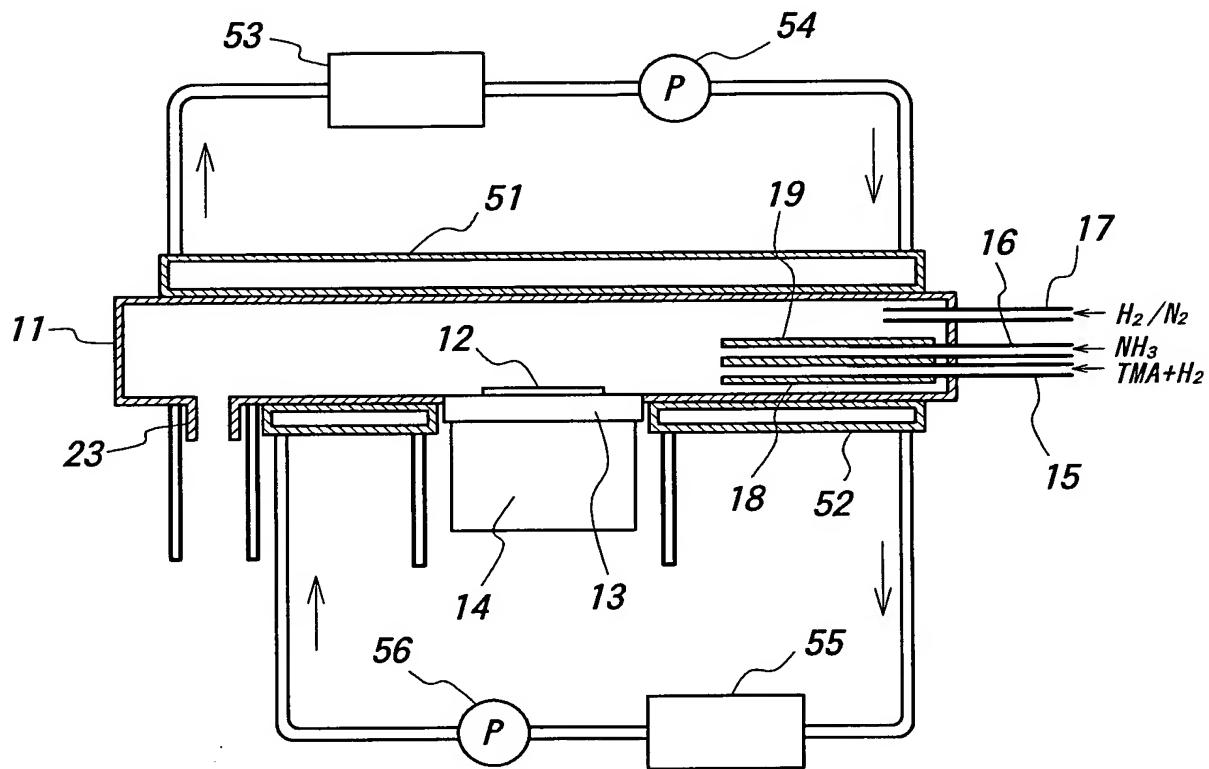
Applicant(s): Tomohiko SHIBATA, Yukinori NAKAMURA and Mitsuhiro TANAKA

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THE SAME

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*FIG. 4*



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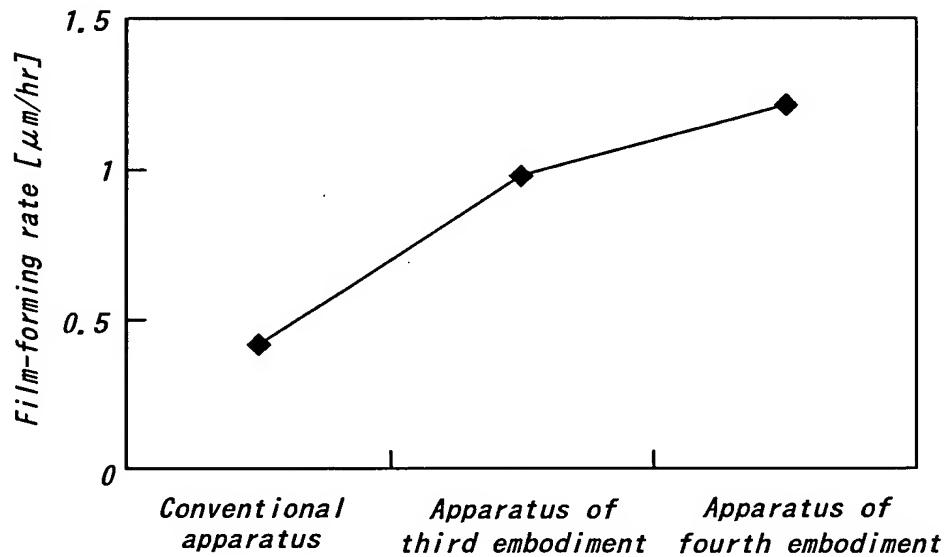
Applicant(s): Tomohiko SHIBATA, Yukinori NAKAMURA and Mitsuhiro TANAKA

Title: A METHOD FOR FABRICATING A III-V NITRIDE FILM AND AN APPARATUS FOR FABRICATING THE SAME

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**FIG. 5**



**FIG. 6**

